



JFW

Docket No.: 057810-0074

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Isao Hasegawa, et al.	:	Confirmation Number: 7087
Application No.: 10/659,346	:	Group Art Unit: 2812
Filed: September 11, 2003	:	Examiner: Schillinger, Laura M.
For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE	:	

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated June 28, 2005.